



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Zhiping Yin
Gurtej S. Sandhu

Serial No.: 10/671,186

Filed: September 24, 2003

For: **ANTIREFLECTIVE COATING FOR USE
DURING THE MANUFACTURE OF A
SEMICONDUCTOR DEVICE**

§
§ Group Art Unit: 2813
§
§ Examiner: Thanh T. Nguyen
§
§ Atty. Docket No.: 2003-0790.00/US
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§ Confirmation No.: 7228
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§

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on or before the date below:

July 13, 2005
Date

Maria Helms
Signature

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Applicant submits that each one of the claims of the captioned application is allowable over the cited art for reason of the cited art failing to disclose or suggest the features and/or combination of features as are defined therein. Although applicant acknowledges the Examiner's "Statement of Reasons for Allowance" as set forth with the Notice of Allowance dated April 13, 2005, applicant submits that the reasons for allowance as provided by the Examiner may represent merely a portion of all of the reasons that support the patentability of the claims of the present application without necessarily being exhaustive.

If there are any matters which may be resolved or clarified through a telephone call, the Examiner is cordially invited to contact the undersigned.

Respectfully submitted,

Kevin D. Martin

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